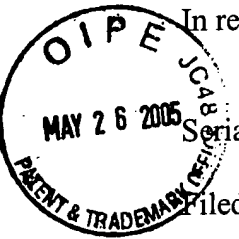


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THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Applicant:

Kramadhathi V. Ravi et al.

Serial No.: 10/809,243

Filed: March 25, 2004

For: Low Dielectric Constant
Carbon Films

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Art Unit: 2826

Examiner: Tuan N. Quach

Atty Docket: ITL.1126US
P19032

Assignee: Intel Corporation

Mail Stop **Amendment**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

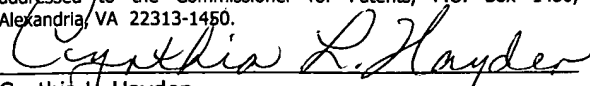
REPLY TO PAPER NO. 0305

Sir:

In response to the office action mailed March 24, 2005, please amend the above-referenced patent application as follows:

Date of Deposit: May 24, 2005

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


Cynthia L. Hayden